

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Seleznev, <i>et al</i>	Examiner:	To be assigned
Serial No.:	To be assigned	Art Unit:	
Filing Date:	herewith		
Title:	VACUUM PROCESSING FOR FABRICATION OF SUPERCONDUCTING THIN FILMS FABRICATED BY METAL- ORGANIC PROCESSING		

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**Preliminary Amendment**

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 3 of this paper.

**Remarks** begin on page 3 of this paper.